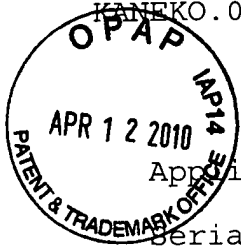


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant : Minoru Umemoto et al.) Group Art Unit
)
 Serial No. : 10/585,707)
)
 Filed : July 19, 2006)
)
 For : PROCESS OF FORMING)
 ULTRAFINE CRYSTAL LAYER,)
 MACHINE COMPONENT HAVING)
 ULTRAFINE CRYSTAL LAYER)
 FORMED BY THE ULTRAFINE)
 CRYSTAL LAYER FORMING)
 PROCESS, PROCESS OF)
 PRODUCING THE MACHINE)
 COMPONENT, PROCESS OF)
 FORMING NANOCRYSTAL LAYER,)
 MACHINE COMPONENT HAVING)
 NANOCRYSTAL LAYER FORMED)
 BY THE NANOCRYSTAL LAYER)
 FORMING PROCESS, AND)
 PROCESS OF PRODUCING THE)
 MACHINE COMPONENT)
)
 Examiner : Unknown)
)

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to the duty of disclosure, enclosed is a form PTO-1449 listing one reference relevant to the above-identified application. A copy of each of the references is also enclosed herewith. This information disclosure statement is being filed after three months from the filing date of the above-identified application and after the first office action on the merits. Thus,

Serial No. : 10/585,707
Filed : July 19, 2006

the fee for submission of Information Disclosure Statement Under 37 C.F.R. § 1.17(p) is enclosed herewith.

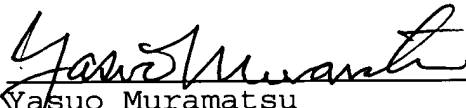
The prior art references enclosed was cited in the counterpart Japanese application of the instant case. A copy of the office action issued by Japanese Patent Office is also enclosed.

The applicant respectfully requests that the references disclosed in the statement be considered in the substantive examination of this case.

Respectfully submitted,

MURAMATSU & ASSOCIATES

Dated: 3/29/2010

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